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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ming Michael Li
Filed : February 6, 2002
For : FORMATION OF MICRO ROUGH POLY SURFACE
FOR LOW SHEET RESISTANCE SALICIDED SUB-
QUARTER MICRON POLY LINES



Docket No. : 97-P-149D1 (850063.518D1)
Date : February 6, 2002

Box Patent Application
Commissioner for Patents
Washington, DC 20231

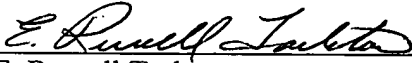
INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicant wishes to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449. This application relies, under 35 U.S.C. § 120, on the earlier filing date of prior Application No. 09/126,960, filed July 31, 1998. The references listed on the attached Form PTO-1449 were submitted to and/or cited by the Patent and Trademark Office in this prior application and, therefore, are not required to be provided in this application. If the Examiner wishes, copies will be provided upon request. As to any reference supplied, applicant does not admit that it is "prior art" under 35 U.S.C. §§ 102 or 103, and specifically reserves the right to traverse or antedate any such reference, as by a showing under 37 C.F.R. § 1.131 or other method. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicant's duty to disclose all information he is aware of which is believed relevant to the examination of the above-identified application, applicant believes that his invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,
Ming Michael Li
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ERT:aep

Enclosures:
Form PTO-1449

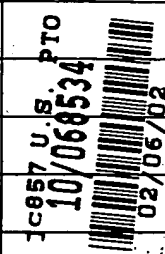
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Sheet 1 of 1

FORM PTO-1449 (REV.7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 97-P-149D1 (850063.518D1)	EXPRESS MAIL NO. EL897859635US
INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>		APPLICANT Ming Michael Li	
		FILING DATE February 6, 2002	GROUP ART UNIT

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5,182,232	01/26/93	Chhabra et al.	437	200	
AB	5,394,012	02/28/95	Kimura	257	739	
AC	5,418,188	05/23/95	Harper et al.	437	200	
AD	5,585,295	12/17/96	Wu	437	44	
AE	5,599,746	02/04/97	Lur et al.	437	200	
AF	5,767,013	06/16/98	Park et al.	438	622	
AG	5,877,063	03/02/99	Gilchrist	438	398	
AH	5,993,685	11/30/99	Currie et al.	252	79.1	
AI	6,074,926	06/13/00	Cathey et al.	438	398	
AJ						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
				YES	NO
AK					
AL					
AM					
AN					
AO					

OTHER PRIOR ART *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	AP	Chang, C.Y. and Sze, S.M., "ULSI Technology," 1996, The McGraw-Hill Companies, Inc., pp. 229, 395-397
	AQ	Wolf, S., "Silicon Processing for the VLSI Era," Vol. 2 – Process Integration, 1990, Lattice Press, pp. 45, 354-357
	AR	

EXAMINER	DATE CONSIDERED
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* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).